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CONFIRMATION NO. 4485

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| 10/539,571 | 06/17/2005 | 220 | 3781 | 273959US26XPCT | | |
| RULE | | | | | | |
| APPLICANTS Toru Kimura, Yokohama-shi, JAPAN; Hiroshi Narushima, Nirasaki-shi, JAPAN; Tsutomu Hiroki, Nirasaki-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/16091 12/16/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-364581 12/17/2002 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/01/2006 | | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/ROBIN A. HYLTON/</u> Examiner's Signature | | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 6 | TOTAL CLAIMS 12 | INDEPENDENT CLAIMS 1 |
| ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, L.L.P. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES | | | | | | |
| TITLE vacuum container apparatus used for manufacturing semiconductor devices and lid appartus for same | | | | | | |
| FILING FEE RECEIVED 900 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |